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SERIAL NUMBER 10/750,021	FILING DATE 12/30/2003  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 51876P542
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*  
 NONE QW

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 REPUBLIC OF KOREA 2003-43071 06/30/2003 ✓ QW

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 05/04/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: [Signature] Initials: QW	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 15	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
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TITLE  
 Method for fabricating semiconductor device having trench type device isolation layer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of
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